

SUPPORT DEVICE FOR A PLURALITY OF WAFERS FOR A VERTICAL OVEN**Abstract**

This support device has a central axis and includes: - three uprights (130), (131) and (132) extending substantially parallel to the central axis, - a plurality of series of support members spaced along the central axis, each series of support members comprising three support members (140), (141) and (142) adapted to support one wafer (W) of the plurality of wafers and extending in different essentially longitudinal directions transverse to the central axis, each support member (140), (141) and (142) being mounted directly on a separate upright, this support device being remarkable in that the directions of the three support members (140), (141) and (142) of each series of support members (135) are concurrent at a point on the central axis.

[FIGURE 3B]